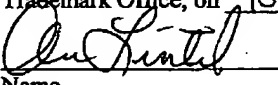


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Park, et al.	Group Art Unit: 2814
Application No.: 09/173,129	Examiner: Peralta, G.
Filed: 10/15/1998	Tech Grp Fax: TC 2800 AF: 703-872-9319
Title: Selective Oxidation for Semiconductor Device Fabrication	I hereby certify that this correspondence is being <input type="checkbox"/> deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, Washington, D.C. 20231, or <input checked="" type="checkbox"/> facsimile transmitted to the U.S. Patent and Trademark Office, on <u>10/23/2003</u> .
Attorney Docket No.: TI-25320	 Name <u>10/23/2003</u> Date

Commissioner for Patents
Washington, D.C. 20231

PETITION FOR EXTENSION OF TIME UNDER 37 CFR §1.136

Dear Sir:

Applicant hereby petitions for an Extension of Time for responding to the Office Action dated May 23, 2003, for **two months** from August 23, 2003 to October 23, 2003.

The Commissioner is hereby authorized to charge the amount of \$ 420.00 plus any other fees or credit any overpayment to Deposit Account No. 20-0668 of Texas Instruments Incorporated.

This petition is submitted in duplicate.

Respectfully Submitted,


Alan W. Lintel
Attorney/Agent for Applicant(s)
Reg. No. 32478

October 22, 2003
Anderson, Levine & Lintel, LLP
14785 Preston Rd.
Suite 650
Dallas, Texas 75254
Tel. (972) 664-9595